# Monthly LabAdviser/Process2Share update: 24/11 2014

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| Updated Subject  | Contributor | Link to the updated pages |
| **SU8 (add to Process2Share)**Added Ph.d. thesis on SU8 processingAdded presentation from Ph.d. defense | **Thomas Anhøj****@danchip** | [http://process2share.danchip.dtu.dk/index.php/Projects,\_Theses\_and\_Papers/Ph.D\_Projects](http://process2share.danchip.dtu.dk/index.php/Projects%2C_Theses_and_Papers/Ph.D_Projects)<http://process2share.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Photolithography/SU8> |
| **UV lithography**Info added on UV exposure dose. | **Thomas Anhøj****@danchip** | [UVExposure\_Dose](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/UVExposure_Dose) |
| **Lithography/Baking**Baking page updated | **Thomas Anhøj****@danchip** | [Baking](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/Baking) |
| **Wafer and sample drying**Updated page on wafer and sample drying | **Karen Birkelund****@danchip** | [Wafer\_and\_sample\_drying](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Wafer_and_sample_drying) |
| **Thin film deposition**Updated material list | **Jesper Hanberg****@danchip** | [Thin\_film\_deposition](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition) |
| **UV lithography – TMAH developer**Information on the newly released TMAH developer | **Thomas Anhøj****@danchip** | [Development#Developer-TMAH](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/Development#Developer-TMAH)[Developer\_TMAH\_UV-lithography\_processing](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/Development/Developer_TMAH_UV-lithography_processing) |

# Equipment Manuals updated in LabManager:

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|  | **Manual for Alcatel** |
|  | **Manual for Wordentec** |
|  | **Manual for Phosphorus Drive-in furnace (A3)** |
|  | **Manual for Phosphorus Predep furnace (A4)** |
|  | **Manual for Apox furnace (D1)** |
|  | **Manual for RTP Jipelec** |
|  | **Manual for BCB Curing Oven** |
|  | **Manual for Thickness Measurer**  |
| http://d4.danchip.dtu.dk/D4Doc/res/menu/user_bullet.gif | **Manual for Nikon ECLIPSE L200 optical microscope** |
|  | [**Manual for Leitz Medilux optical microscope**](http://d4.danchip.dtu.dk/D4Doc/book/docshow.asp?DokID=2531&sText=Manual) |
|  | **Manual for Leica S8 APO optical microscope** |
|  | **Manual for Zeiss Jenatech (particle measturements) optical microscope** |
|  | **Manual for Four point probe** |
|  | **Manual for III-V oxide furnace** |

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